

JPW



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

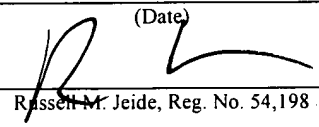
Applicants : Solanki, et al.
Appl. No. : 10/627576
Filed : July 24, 2003
For : METHOD FOR MAKING THIN FILM
DEVICES FOR SOLAR CELLS OR
SILICON-ON-INSULATOR (SOI)
APPLICATIONS
Examiner : Tuan H. Nguyen
Group Art Unit : 2813

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 10, 2005

(Date)


Russell M. Jeide, Reg. No. 54,198

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement mailed December 14, 2004, in the above-identified application, Applicants elect Group II, Claims 1-8 and 14-21, which are drawn to a method of manufacturing a semiconductor device. Please withdraw the claims of Group I (Claim 9) and Group III (Claims 11-13) without prejudice. Applicants reserve the right to pursue the non-elected claims in one or more continuing applications.

If the Examiner has any questions regarding the above election or would like to discuss this response further, he is cordially invited to contact the undersigned so that any such questions may be promptly resolved.

RECEIVED
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Appl. No. : 10/627576
Filed : July 24, 2003

REMARKS

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

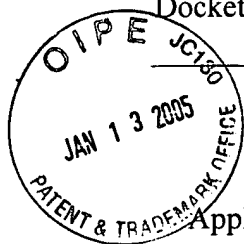
Dated: _____

11/10/05

By: _____

Russell M. Jeide
Registration No. 54,198
Attorney of Record
Customer No. 20,995
(619) 235-8550

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AMENDMENT / RESPONSE TRANSMITTAL

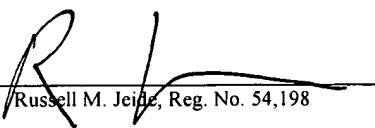
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 Russell M. Jeide, Reg. No. 54,198
Mail Stop Amendment

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:


(X) Response to Restriction Requirement in 2 pages.

The fee has been calculated as shown below:

FEE CALCULATION				
FEE TYPE		FEE CODE	CALCULATION	TOTAL
Total Claims	21 - 21 = 0	2202 (\$25)	x * =	\$0
Independent Claims	6 - 6 = 0	2201 (\$100)	0 x * =	\$0
			TOTAL FEE DUE	\$0

(X) Return prepaid postcard.

(X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.


 Russell M. Jeide
 Registration No. 54,198
 Attorney of Record
 Customer No. 20,995
 (619) 235-8550